



Image Rec 18825  
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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi TANAKO

Application No.: 09/819,690

Filed: March 29, 2001

For: SEMICONDUCTOR, MANUFACTURING METHOD, SUBSTRATE PROCESSING METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

MAIL STOP RCE

Group Art Unit: 2825

Examiner: G. Lee

Docket No.: 109107

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

Applicant further requests entry and consideration of the submission filed October 3, 2003.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 149823 in the amount of  \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Phillip D. Mancini  
Registration No. 46,743

01/06/2004 JADD01 00000105 09819690

01 FC:1801

770.00 OP

JAO:PDM/ccs

Date: January 5, 2004

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Alexandria, Virginia 22320  
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